

In re application of:

Sytsma et al.

Appl. No.: 10/790,257

Filed: March 2, 2004

For: Lithographic Apparatus and Device Manufacturing Method

Confirmation No.: 9806

Art Unit: 2851

Examiner: Hung Nguyen

Atty. Docket: 1857.2690000

Amendment and Reply Under 37 C.F.R. § 1.111

Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated October 5, 2005, Applicants submit the following Amendment and Reply.

It is not believed that extensions of time or fees for net addition of claims are required beyond those that may otherwise be provided for in documents accompanying this paper. However, if additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefore (including fees for net addition of claims) are hereby authorized to be charged to our Deposit Account No. 19-0036.





Robert Greene Sterne Edward J. Kessler Jorge A. Goldstein David K.S. Cornwell Robert W. Esmond Tracy-Gene G. Durkin Michele A. Cimbala Michael B. Ray Robert E. Sokohl Eric K. Steffe Michael Q. Lee Steven R. Ludwig John M. Covert Linda E. Alcom Robert C. Millonig Donald J. Featherstone Timothy J. Shea, Jr Milchael V. Messinger Judith U. Kim
Patrick E. Garrett
Jeffrey T. Helvey
Heldi L. Kraus
Eldora L. Ellison
Thomas C. Fiala
Donald R. Banowit
Peter A. Jackman
Jeffrey S. Weaver
Kendrick P. Patterson
Vincent L. Capuano
Brian J. Del Buono
Virgil Lee Beaston
Theodore A. Wood
Elizabeth J. Haanes
Joseph S. Ostroff
Frank R. Cottingham
Rae Lynn P. Guest

Daniel A. Klein
Jason D. Eisenberg
Michael D. Specht
Tracy L. Muller
Jon E. Wright
LuAnne M. DeSantis
Ann E. Summerfield
Helene C. Carlson
Cynthia M. Bouchez
Timothy A. Doyle
Gaby L. Longsworth
Lori A. Gordon
Nicole D. Dretar
Ted J. Ebersole
Laura A. Vogel
Bryan S. Wade
Aaron L. Schwartz
Shannon A. Carroll*

wesley W. Jones*
Matthew E. Kelley*
Michelle K. Holoubek*
Marsha A. Rose*

antis
Registered Patent Agents*
field Karen R. Markowicz
on Nancy J. Leith
chez Matthew J. Dowd
e Katrina Yujian Pel Quach
orrth Bryan L. Skelton
Robert A. Schwartzman
Teresa A. Colella
Victoria S. Ruttherford
Simon J. Elliott

Julie A. Heider

Mita Mukherje

Scott M. Woodhouse

Attn: Mail Stop Amendment

Christopher J. Walsh Liliana Di Nola-Baron Peter A. Socarras Jeffrey Mills Danielle L. Letting

Leith Of Counsel

J. Dowd Geneth C. Bass III
Skelton Marvin C. Guthrie
Schwartzman
Colella

*Admitted only in Maryland *Admitted only in Virginia •Practice Limited to Federal Agencies

December 29, 2005

WRITER'S DIRECT NUMBER: (202) 772-8645 INTERNET ADDRESS: JASONE@SKGF.COM

Art Unit 2851

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Re:

U.S. Utility Patent Application

Application No. 10/790,257; Filed: March 2, 2004

For: Lithographic Apparatus and Device Manufacturing Method

Inventors: Sytsma *et al.*Our Ref: 1857.2690000

Sir:

Transmitted herewith for appropriate action are the following documents:

- 1. Amendment and Reply Under 37 C.F.R. § 1.111; and
- 2. Return postcard.

It is respectfully requested that the attached postcard be stamped with the date of filing of these documents, and that it be returned to our courier. In the event that extensions of time are necessary to prevent abandonment of this patent application, then such extensions of time are hereby petitioned.

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted,

Sterne, Kessler, Goldstein & Fox p.l.l.c.

JDE/lvt Enclosures

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Sterne, Kessler, Goldstein & Fox PLLC. : 1100 New York Avenue, NW : Washington, DC 20005 : 202.371.2600 f 202.371.2540 : www.skgf.com

fan

Vason D. Eisenberg
Attorney for Applicants
Registration No. 43,447